



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

November 18, 2024	
IGI Report Number	LG663405886
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PEAR MODIFIED BRILLIANT
Measurements	10.27 X 6.72 X 4.23 MM

GRADING RESULTS

Carat Weight	2.10 CARATS
Color Grade	FANCY INTENSE YELLOW
Clarity Grade	VVS 2

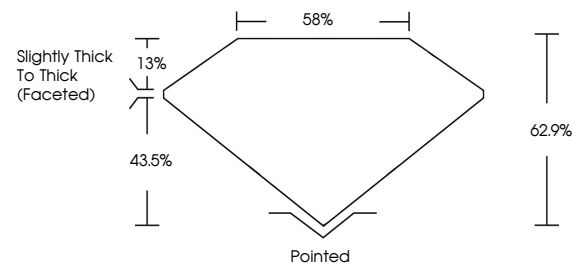
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG663405886

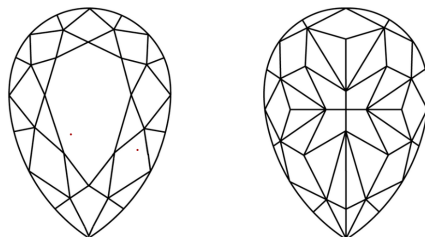
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG663405886
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF WS¹⁻² VS¹⁻² SI¹⁻² |¹⁻³

Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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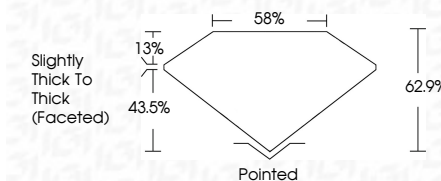
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November 18, 2024	GL Report No. GSA450866	2
PEAR MOONED BRILLIANT		
2027 X 4.72 X 4.23 MM	Carat Weight	FANCY (MBS)
	Color Grade	
	Clarity Grade	
	Depth	
	Table	
	Grade	
	Quiet	Slightly TN
	Polish	
	Symmetry	
	Fluorescence	
	Inscriptions(s)	681
Comments:		
The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.		

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created by Chemical Vapor Deposition